

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): HIMI et al.	Atty. Dkt.: 01-100-DIV
Serial No.: Unknown	Group Art Unit:
Filed: Concurrently herewith	Examiner:
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR SUBSTRATE	

Date: November 20, 2003

Honorable Commissioner for Patents  
Arlington, VA 22202

**PRELIMINARY AMENDMENT**

Sir:

Prior to the initial examination of the above-referenced application, please enter the following amendments and consider the appended remarks.

**Amendments to the Specification** begin on page 2 of this paper.

**Listing of Claims** begins on page 3 of this paper.

**Remarks** begin on page 9 of this paper.